

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: UKITA, M. **ATTY DOCKET NO.:** 09792909-5784
SERIAL NO.: Not yet assigned **GROUP ART UNIT:** not yet assigned
DATE FILED: November 24, 2003 **EXAMINER:** not yet assigned
INVENTION: SEMICONDUCTOR LASER AND PRODUCTION METHOD THEREOF

which is a Divisional of the following copending U.S. Application:

APPLICANT: UKITA, M. **ATTY DOCKET NO.:** 09792909-5449
SERIAL NO.: 10/191,151 **GROUP ART UNIT:** 2812
DATE FILED: July 9, 2002 **EXAMINER:** Mulpuri, S.
INVENTION: SEMICONDUCTOR LASER AND PRODUCTION METHOD THEREOF

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please amend the accompanying application as follows:

In the Specification

On page 1, after the title and before the heading, "Background of the Invention,"
please insert the following:

--RELATED APPLICATION DATA

The present application claims priority to Japanese Application No. P10-351623
filed December 10, 1998, and is a divisional of United States Application Serial No.
10/191,151, filed July 9, 2002 which is a divisional of United States Application Serial No.
09/457,133, filed December 9, 1999 now issued United States Letters Patent No. 6,470,039,
issued on October 22, 2002, all of which are incorporated herein by reference to the extent
permitted by law.--